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Practitioner's Docket No. 13621-43433

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hoover, Brian G.

Application No.: 10/625,769

Group No.: 3738

Filed: July 23, 2003

Examiner:

For: CORNEAL IMPLANTS PRODUCED BY IRRADIATION OF POLYMER FILMS

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Complete if Known

Application Number	10/625,769
Filing Date	07/23/2003
First Named Inventor	Brian G. Hoover
Art Unit	3738
Examiner Name	
Attorney Docket Number	13621-43433

Sheet	1	of	1
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U. S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

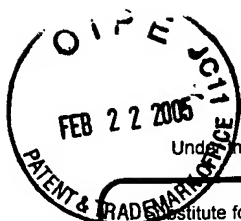
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Complete if Known	
				Application Number	10/625,769
				Filing Date	07/23/2003
				First Named Inventor	Brian G. Hoover
				Art Unit	3738
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	13621-43433

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T ²
	A	WOLF, STANLEY PH.D. AND TAUBER, RICHARD N. PH.D., "SILICON PROCESSING FOR THE VLSI ERA, Volume 1: Process Technology," Book, 1st ed., Lattice Press (Sunset Beach, California), p. 430-437, (February 8, 1986).		
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	C	FERAIN, E.AND LEGRAS, R., "Track-etched membrane: dynamics of pore formation," Journal, Elsevier Science B.V. (North Holland), No. B84, p. 331-336, (February 8, 1994).		
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	E	VALIEV, K.A.; VELIKOV, L.V.; DUSHENKOV, S.D., "Pore formation in PMMA during x-ray exposure," Journal, Sov. Phys. Tech. Phys. (USSR), Vol. 32 (No. 7), p. 862-863, (February 8, 1988).		
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	G	HICKS, C. et al., "Development and Clinical Assessment of an Artificial Cornea," Journal, Progress in Retinal and Eye Research, Elsevier Science Ltd. (Great Britain), Vol. 19 (No. 2), p 149-170 (2000).		
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	I	VIRK, H.S., et al., "Effects on insulators of swift-heavy-ion irradiation: ion-track technology," Journal, J. Phys. D: Appl. Phys., IOP Publishing Ltd. (UK), Vol. 31, p. 3139-3145, (1998).		
	J	YASHAR, Alyson G., "Artificial iris device may reduce glare," Magazine, Opthamalogy Times, Advanstar Communications, Inc., (September 15, 2000)		

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